



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : A. Bashore

For : Ion-Assisted Deposition Techniques for
the Planarization of Topological Defects

**APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS and
TELEPHONE NUMBER**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified
application to:

John P. Wooldridge
114 Honu'ea Place
Kihei, HI 96753

Please change the telephone number for the above-identified application to:

808-875-0012

If you have any questions, please contact the undersigned at 808-875-0012.

Respectfully submitted,

John P. Wooldridge
Attorney for Applicant
Registration No. 38,725

Dated: February 20, 2007